

03500.015730.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
: Examiner: P. Macchiarolo  
TAKASHI IWAKI ET AL. )  
: Group Art Unit: 2875  
Application No.: 09/941,782 )  
:  
Filed: August 30, 2001 )  
:  
For: ELECTRON-EMITTING DEVICE, )  
ELECTRON SOURCE AND METHOD :  
FOR MANUFACTURING )  
IMAGE-FORMING APPARATUS : November 18, 2004

**Mail Stop RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

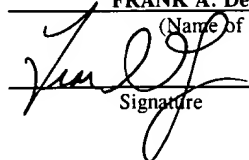
In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in  
accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope  
addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria,  
VA 22313-1450 on November 18, 2004.

(Date of Deposit)

FRANK A. DeLUCIA (REG. NO. 42,476)

(Name of Attorney for Applicant)



Signature

November 18, 2004

Date of Signature

directed to the documents listed on the enclosed Form PTO-1449. Copies of the documents are enclosed.

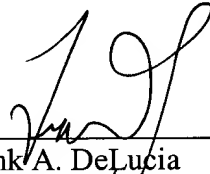
For the concise explanation of relevance for the non-English document JP 08-55563, the Examiner is respectfully referred to the English abstract attached thereto.

Also, for the concise explanation of relevance for the non-English document JP 08-55571, the Examiner is respectfully referred to the English abstract attached thereto.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

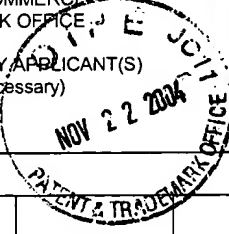
Respectfully submitted,



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Frank A. DeLucia  
Attorney for Applicants  
Registration No.: 42,476

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3800  
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465722v1

FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. <b>03500.015730</b>		APPLICATION NO. <b>09/941,782</b>	
				APPLICANT <b>TAKASHI IWAKI ET AL.</b>			
				FILING DATE <b>AUGUST 30, 2001</b>		GROUP <b>2875</b>	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		<b>08-55563</b>	<b>2/1996</b>	<b>JAPAN</b>			<b>Abstract</b>
		<b>08-55571</b>	<b>2/1996</b>	<b>JAPAN</b>			<b>Abstract</b>
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.